



On the improvement of photoelectrochemical performance and finite element analysis of reduced graphene oxide–BiVO₄ composite electrodes



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ABSTRACT

Incorporation of thermally reduced graphene oxide (RG-O) into the metal oxide semiconductor BiVO₄ improves its photoactivity by about three times for sulfite oxidation. The enhancement of photoactivity is attributed to reduced electron–hole recombination of BiVO₄ using the RG-O as a conductive matrix in the composite photocatalyst. Photoelectrochemical behavior of the BiVO₄ and RG-O/BiVO₄ composite electrodes were simulated using finite element analysis to obtain the carrier mobility and its lifetime in the photoelectrodes. In contrast with sulfite oxidation, the improvement of photocurrent for water oxidation of RG-O/BiVO₄ composite electrode was not significant because of the slower kinetics for water oxidation. To address the kinetic limitations, platinum (Pt) as an effective electrocatalyst was photodeposited on the RG-O/BiVO₄ electrode. Addition of the Pt significantly improved water oxidation photocurrent of the Pt/RG-O/BiVO₄ electrode. RG-O/W–Mo-doped BiVO₄ composite electrodes were also prepared to investigate a further enhancement of photoactivity of W–Mo-doped BiVO₄. The behavior obtained from RG-O/W–Mo-BiVO₄ and RG-O/BiVO₄ electrodes provides a valuable insight into the role of RG-O as a conducting additive and the role of W and Mo as dopants into BiVO₄.

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1. Introduction

Metal oxide semiconductors, e.g., TiO₂, Fe₂O₃, WO₃ and BiVO₄, have been extensively studied as water oxidation photocatalysts for the possible solar photolysis of water [1]. Metal oxide semiconductors are chemically stable, cheap and abundant, and their semiconducting properties, such as the size of band-gap, the band-edge locations, and the carrier mobility, can be significantly modified by the addition of dopant, e.g., Si-doped Fe₂O₃ [2], N-doped WO₃ [3], and W-doped BiVO₄ [4,5]. However, significant electron–hole recombination, indicated by the short minority carrier-lifetime and short carrier-diffusion length of metal oxide semiconductors remains a major barrier to achieving a high conversion efficiency of sunlight to chemical energy, i.e., for hydrogen production by water splitting [6–8]. Methods of increasing the carrier mobility, e.g., by doping or the addition of conductive or electron accepting materials into the metal oxide semiconductor have been recently attempted to address the rapid electron–hole recombination of the photocatalysts. For example, conductive TiSi₂ was incorporated into TiO₂ [9,10], WO₃ [11], and α-Fe₂O₃ [12] to improve the electron transport through the electrodes. Also, composite photocatalysts with carbon based conducting materials, such as carbon

nanotube or reduced graphene oxide (RG-O), have also been suggested for TiO₂ [13–15] and BiVO₄ [16] to overcome the rapid recombination of excited electron–hole pairs; the addition of conductive materials into semiconductors increases the rate at which electrons are transported from the semiconductor/solution interface and hence the separation of electron–hole pairs. However, conductive materials can also act as traps, i.e., recombination centers for the electron–hole pairs [17].

The chemistry of graphite oxide (GO) and later graphene oxide (G-O) has been extensively studied for its properties and synthesis since the first report of GO in 1859 [18]. G-O is intrinsically an insulator, but it is used as a precursor for graphene-like material, i.e., reduced graphene oxide (RG-O). G-O is a possible source for the mass production of RG-O, and chemical derivatives of G-O and RG-O are promising materials for such applications as polymer nanocomposites, ultracapacitors, rechargeable batteries, sensors, and thin films [19–23]. Among such applications, RG-O (or G-O) composites with semiconductor photocatalysts have been reported to enhance photoactivity with the RG-O as a conductive additive to improve the bulk conductivity and facilitate electron–hole separations in photocatalysts as described above [14–16]. Here, we report the facile preparation and photoelectrochemical (PEC) behavior of RG-O/metal oxide composite photocatalysts based on BiVO₄ and W–Mo-doped BiVO₄. We also report a simulation (finite element analysis) of the PEC properties [24–26]. BiVO₄, with a band gap

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of 2.4 eV, is a visible light water oxidation photocatalyst. Moreover, W-doped BiVO₄ or W–Mo-doped BiVO₄ produces a photocurrent for water oxidation that is more than 10 times higher than undoped BiVO₄ [4,5]. BiVO₄ or W–Mo-doped BiVO₄, were employed in a simple two-step process to fabricate composite electrodes in which G-O is exfoliated and homogeneously dispersed ultrasonically in ethylene glycol solution and then thermally reduced during metal oxide formation by thermal annealing of drop-cast electrodes in air. In addition, in some experiments a Pt electrocatalyst was photodeposited onto the composite electrodes to decrease kinetic limitations of the water oxidation reaction on the composite electrodes; the effect of reduced electron–hole recombination by incorporation of RG-O clearly results in an increased photocurrent after the surface treatment.

2. Experimental

2.1. Chemicals

Bi(NO₃)₃·5H₂O (99.999%) and (NH₄)₁₀H₂(W₂O₇)₆·xH₂O (99.99%) were obtained from Strem Chemicals (Newburyport, MA). H₂SO₄ (98%), HCl (Technical grade), KMnO₄ (99.6%), Na₂HPO₄ (99.9%), NaH₂PO₄ (99.5%), MeOH (99.8%), and ethylene glycol were purchased from Fisher Scientific (Pittsburg, PA). H₂O₂ (30 wt% in water), H₂PtCl₆·xH₂O (99.9%), (NH₄)₆Mo₇O₂₄·4H₂O (99.98%), and Na₂SO₄ (99.0%) were purchased from Sigma–Aldrich (St. Louis, MO). VCl₃ (99%, Alfa-Aeser, Ward Hill, MA) and Na₂SO₃ (99.6%, Mallinckrodt Baker, Phillipsburg, NJ) were used as received. Fluorine-doped tin oxide (FTO, TEC 15, Pilkington, Toledo, OH) was used as a substrate of the electrodes. Deionized (DI) Milli-Q water was used as the solvent in electrochemical experiments.

2.2. Graphene oxide (G-O) preparation

Graphite oxide (GO) was synthesized by a modified Hummer's method [27]. Briefly, 100 mg of natural graphite (SP-1, Bay Carbon, Bay City, MI) was mixed with 50 mL concentrated H₂SO₄ in a flask, followed by the addition of 500 mg of KMnO₄. After addition of KMnO₄, the mixture was heated at 35 °C and stirred for 2 h. Excess DI water (50 mL) was added to the flask (placed in an ice bath), and then more water (100 mL) was added followed by stirring in the ice bath for 1 h. H₂O₂ (30 wt% in water) was then added to the mixture until no further gas evolution was observed, followed by stirring for 2 h. The final suspension was filtered and washed with HCl (10% in water) and dried in air. Suspensions of G-O platelets were prepared using an ultrasonic bath (2510R-MT, Branson, Danbury, CT) by sonication of GO in DI water or ethylene glycol for 1 h.

2.3. Electrodes

Thin film electrodes of the BiVO₄ (or BiVO₄ with 2 atomic% (at%) W and 6 at% Mo, 'W–Mo-doped BiVO₄') and RG-O/BiVO₄ (or RG-O/W–Mo-doped BiVO₄) composites were prepared on an FTO substrate by drop casting the precursor solution. The metal oxide films were cast using 100 μL of a precursor solution with a total concentration of 20 mM in ethylene glycol. For RG-O/metal oxide composite electrodes, the targeted amount of GO powder was suspended in the metal oxide precursor solution and the solution was ultrasonicated for 1 h before drop casting. Then, the film was annealed in air for 3 h at temperatures from 400 °C to 550 °C, ramped from room temperature at a rate of 1 °C per min.

Photodeposition of Pt on photoelectrodes was conducted in aqueous solution of 10 mM H₂PtCl₆ and 0.2 M MeOH. BiVO₄ (and W–Mo-doped BiVO₄) and its RG-O composite electrodes on FTO were placed in the Pt precursor solution in a borosilicate glass cell.

UV–visible irradiation was then performed at full output with a Xenon lamp (XBO 150 W, Osram, Munich, Germany) for 30 min, and a beam intensity was about 200 mW cm⁻². During the irradiation, photoreduction of Pt occurred on the thin film electrodes while MeOH was oxidized by the photoexcited electron and hole [28].

2.4. Instruments

A CH Instruments Model 630D electrochemical analyzer (Austin, TX) was used as a potentiostat for the experiments with the thin film electrodes. Illumination was with a Xenon lamp (XBO 150 W, Osram) at full output for UV–visible irradiation or using a 420 nm cut-off filter (WBF-3, Oriel, Darmstadt, Germany) for visible irradiation. A Pt gauze counter electrode and Ag/AgCl reference electrode in a saturated KCl solution were used to complete the three-electrode configuration. However, all potentials reported here are with respect to the normal hydrogen electrode (NHE). X-ray diffraction (XRD) measurements were performed using a Bruker–Nonius D8 advanced powder diffractometer (Madison, WI) operated at 40 kV and 40 mA with Cu Kα radiation (λ = 1.54 Å). Grazing incidence XRD (GIXRD) with incidence angle of 1° in detector scan mode was performed to obtain diffractograms from the thin film electrodes on FTO. The scan rate was 12° per minute in 0.02° increments of 2θ from 15° to 80°. Scanning electron microscopy (SEM) images were obtained with a LEO 1530 SEM at a working voltage of 10 kV and working distance of 5 mm. Thermogravimetric analysis (TGA) was conducted from room temperature to 800 °C with a Perkin–Elmer TGA 4000 with a ramp rate of 1 °C per min under dry air flow. X-ray photoelectron spectroscopy (XPS) was performed on a Kratos Axis Ultra DLD instrument (Manchester, UK) with a monochromatic Al X-ray source with 180° hemispherical electron energy analyzer.

2.5. Simulations

Finite element analysis was performed using COMSOL Multiphysics v.3.5 software (Burlington, MA) to study the photoanode properties. The steady state Poisson equation (Eq. (1)) and Nernst–Planck equations (Eqs. (3) and (4)) were used to calculate the potential distribution and the electron–hole transport in the semiconductor electrodes. The physics and reactions used in the simulations are schematically summarized in Fig. 1.

$$d(-\epsilon_0\epsilon_r d\psi/dx)/dx = \rho \quad (1)$$

where ϵ_0 is the vacuum permittivity, ϵ_r is the relative permittivity, ψ is the potential (of Fermi level vs vacuum level), and ρ is the excess charge density. The simulation domain and constants were set as shown in Supporting information Fig. S1; ρ was defined as

$$\rho = (C_p + C_n - N_d)q \quad (2)$$

where q is the electron charge, N_d is the fixed electron doping density at thermal equilibrium, and C_n and C_p is the local carrier density of electrons and holes, respectively. C_n and C_p were determined using the Nernst–Planck equations as shown below.

$$d(-D_n dC_n/dx + \mu_n C_n d\psi/dx)/dx = -R + G \quad \text{for } C_n \quad (3)$$

$$d(-D_p dC_p/dx - \mu_p C_p d\psi/dx)/dx = -R + G \quad \text{for } C_p \quad (4)$$

where D_n and D_p are the diffusion coefficients of electron and hole, and μ_n and μ_p are the mobilities for electrons and holes, respectively. The diffusion coefficient and mobility are related by the Einstein relation.

$$D_{n/p} = \mu_{n/p} kT/q \quad (5)$$

where k is the Boltzmann constant and T is the temperature. R is the electron–hole recombination rate in the bulk semiconductor and

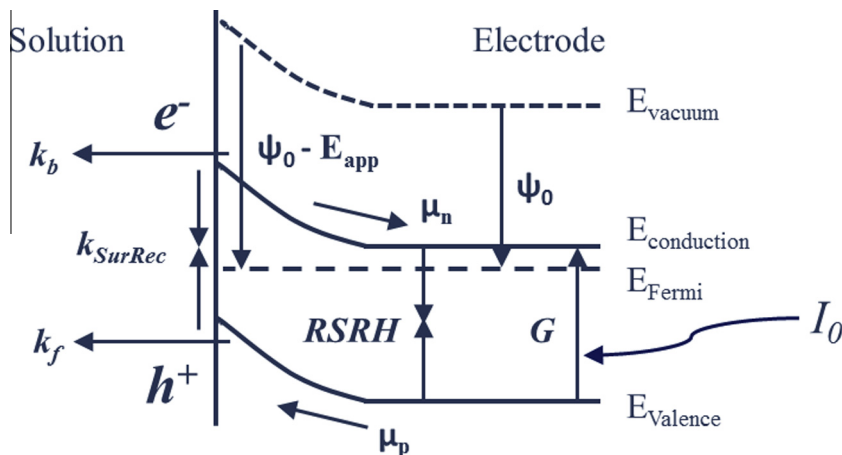


Fig. 1. Schematic diagram of reaction processes of excited electron and hole in the photoelectrodes. RSRH, the Shockley–Read–Hall recombination rate, indicates electron–hole recombination rate in the bulk semiconductor at steady-state (Eq. (6) in the text).

the trap-assisted Shockley–Read–Hall recombination equation was used in the simulations [29].

$$R = (C_n C_p - n_i^2) / (\tau_n (C_p + n_i) + \tau_p (C_n + n_i)) \quad (6)$$

where n_i is the intrinsic doping density and τ_n and τ_p is the recombination lifetime of electrons and holes. Also, the surface recombination of electrons and holes was considered as

$$dC_n/dt = dC_p/dt = -k_{SurRec} C_n C_p \quad (\text{at the electrode surface}) \quad (7)$$

where k_{SurRec} is the rate constant of the surface trap recombination. G in Eqs. (3) and (4) is a generation rate of the charge carriers by the absorbed photon energy.

$$G = I_0 \alpha \exp(-\alpha x) \quad (8)$$

where α is the absorption coefficient of the photoanode, and I_0 is the incidence rate of photon. x is the penetration depth of the photon into the electrode. Initial conditions for ψ , C_n , and C_p were

$$\psi_0 = kT/q(\ln(C_{n0}/n_i) - \chi_{semi} - 0.5E_g) \quad (9)$$

$$C_{n0} = n_d/2 + (n_d^2/4 + n_i^2)^{0.5} \quad (10)$$

$$C_{p0} = n_i^2/C_{n0} \quad (11)$$

where χ_{semi} is the electron affinity of semiconductor electrode, and E_g is the band gap energy of the semiconductor. The density of available states (n_s) was set to obtain the intrinsic doping density (n_i) of photoelectrodes (Eq. (12)). The donor density (n_d) of BiVO_4 was determined from the previously reported experimental values [5].

$$n_i = n_s \exp(-qE_g/2kT) \quad (12)$$

Boundary conditions for ψ , C_n , and C_p at the solution/electrode interface and at the electrode/metal contact were

$$\psi_{\text{solution}} = \psi_0 - E_{app} \quad (13)$$

$$dC_{n_solution}/dx = -k_b C_n C_B - k_{SurRec} C_n C_p \quad (14)$$

$$dC_{p_solution}/dx = -k_f C_p C_A - k_{SurRec} C_n C_p \quad (15)$$

$$\psi_{\text{metal}} = \psi_0 \quad (16)$$

$$C_{n_metal} = C_{n0} \quad (17)$$

$$C_{p_metal} = C_{p0} \quad (18)$$

where E_{app} is the applied potential, and k_f and k_b are the hole and electron transfer rate constants of reactions (19) and (20). C_A and C_B are the molecular concentrations of A and B in the solution.



The chemical species, i.e., A and B , were treated as the sulfite and the dissolved oxygen in the solution. C_A and C_B were assumed as a constant and the reaction rates of (19) and (20) were limited by the electron and hole fluxes at the electrode surface. Then, linear sweep voltammograms (LSVs) of the photoelectrode were simulated as the E_{app} was changed from 0 to 1 V. The photocurrent (i) was calculated from the electron and hole flux at the electrode/metal interface.

$$i = q(dC_p/dx - dC_n/dx) \quad (21)$$

3. Results and discussion

3.1. Experiments with RG-O/ BiVO_4

The photoactivity of BiVO_4 and RG-O/ BiVO_4 composite electrodes were compared under the same conditions for sulfite oxidation as shown in Fig. 2a. For the RG-O/ BiVO_4 electrode, 5 wt% of G-O was added to the precursor solution of BiVO_4 during electrode preparation. The optimum concentration of RG-O in the composite electrode was determined by varying the amount of G-O in the precursor solution and the results are shown in Fig. 3a. 5 wt% G-O in the precursor solution corresponds to $14 \mu\text{g cm}^{-2}$ of G-O in the prepared BiVO_4 electrode. As shown in Fig. 3, the photoactivity of the resulting RG-O/ BiVO_4 was greatly affected by small changes in the G-O concentration in the precursor solution. Note that the weight ratio of G-O is based on the amount of G-O prepared in the precursor solution of the metal salts, and is the ratio of G-O to the total amount of G-O and resulting metal oxide from the metal salts. The amount of RG-O in the resulting electrode is reduced after the thermal annealing process used for electrode fabrication (see TGA results in Supporting information Fig. S2). However, the RG-O/ BiVO_4 electrode prepared from 5 wt% G-O precursor solution showed several times higher photocurrent for sulfite oxidation both under UV–visible and visible light irradiation compared to that of BiVO_4 (see Supporting information Fig. S3 for response to visible light irradiation). As shown below in the finite element analysis, thermally reduced G-O facilitates the transfer of photoex-

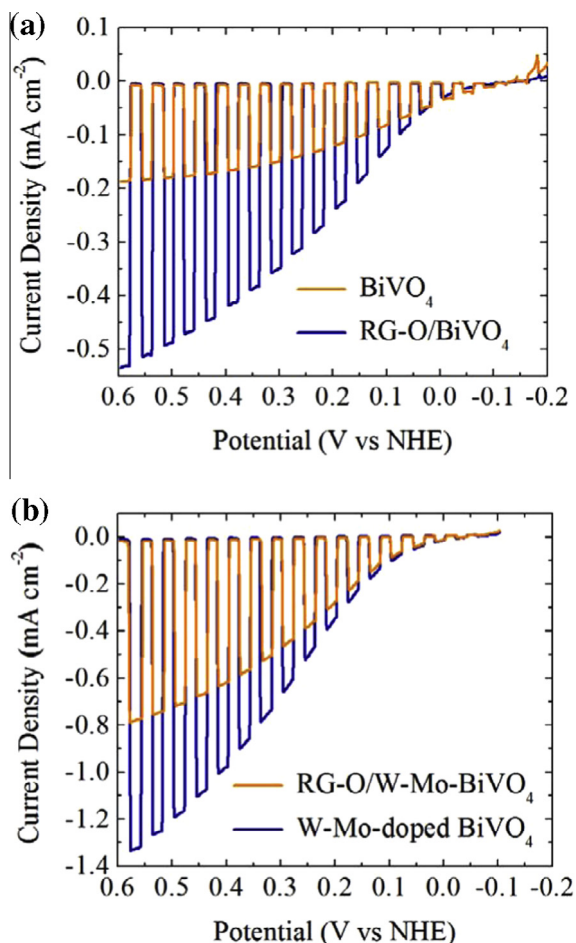


Fig. 2. LSV of (a) BiVO₄ (yellow) and RG-O/BiVO₄ (blue) and (b) W-Mo-doped BiVO₄ (blue) and RG-O/W-Mo-doped BiVO₄ (yellow) for sulfite oxidation in 0.1 M Na₂SO₃ and 0.1 M Na₂SO₄ aqueous solution (pH 7, 0.2 M sodium phosphate buffered). Scan rate was 20 mV s⁻¹ and photocurrent was measured under chopped UV-visible irradiation. Beam intensity was about 120 mW cm⁻². (For interpretation of the references to color in this figure legend, the reader is referred to the web version of this article.)

cited electrons to the back contact, conductive FTO, so the incorporation of RG-O into the photocatalyst results in an improved separation of the excited electron-hole pairs [15].

As known from earlier studies [5] the annealing in air oxidatively converts the metal salts to BiVO₄. However, in this case it also leads to reduction of G-O with either the ethylene glycol or C acting as the reducing agents. The annealing temperature used for the preparation of RG-O/BiVO₄ composite electrodes was also varied (from 400 °C to 550 °C) to observe the effect on the photoactivity of RG-O/BiVO₄ for sulfite oxidation (Fig. 3b). The results show that RG-O/BiVO₄ or BiVO₄ fabricated at 400 °C has a far lower photoactivity, i.e., three times lower photocurrent at 0.5 V compared to those annealed at temperatures above 450 °C. The lower photocurrent of the composite electrodes prepared at 400 °C originated from the low photoactivity of tetragonal scheelite-like BiVO₄. The XRD pattern, shown in Supporting information Fig. S4, indicates that tetragonal scheelite-like BiVO₄ is formed in RG-O/BiVO₄ for the annealing temperature of 400 °C, but the peaks from this tetragonal phase are not observed in RG-O/BiVO₄ at annealing temperatures above 450 °C as shown in Fig. 4. Monoclinic scheelite-like BiVO₄, with a smaller band gap of 2.4 eV, is much more photoactive than the tetragonal scheelite-like BiVO₄ (band gap of 2.9 eV) [30]. In addition, TGA analysis in Supporting information

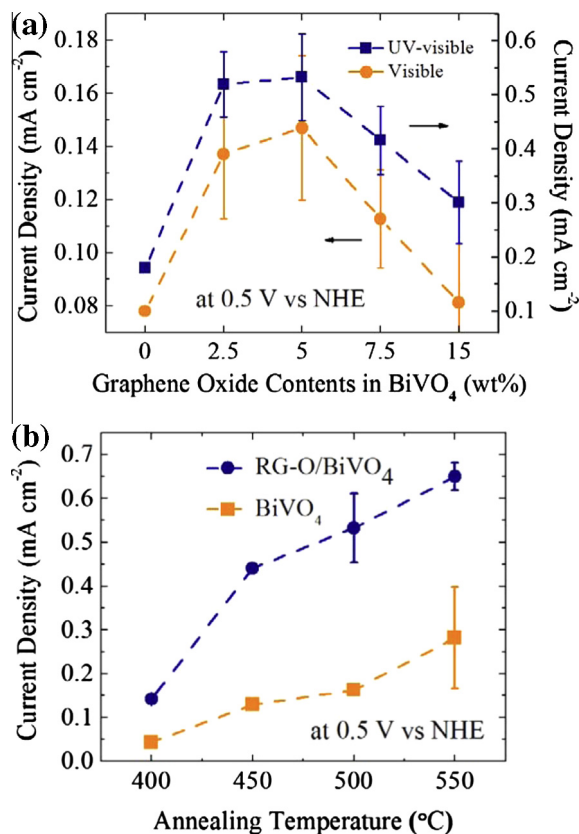


Fig. 3. Photocurrent dependence of RG-O/BiVO₄ composite electrode on the weight ratio of G-O to BiVO₄ for sulfite oxidation (a) and on the annealing temperature on photocurrent of RG-O/BiVO₄ composite electrode for sulfite oxidation (b). RG-O/BiVO₄ composite electrodes were drop-casted on FTO and annealed at 500 °C for 3 h in air in (a). The amount of G-O in the precursor solution was 5 wt% of the resulting BiVO₄ in (b) and RG-O/BiVO₄ composite electrodes were annealed at various temperatures for 3 h in air. The photocurrent was measured at 0.5 V (vs. NHE) in 0.1 M Na₂SO₃ and 0.1 M Na₂SO₄ aqueous solution under UV-visible irradiation. Note that the weight ratio of G-O is based on the G-O prepared in the precursor solution of metal oxide, and the weight ratio of RG-O in the resulting electrode is likely changed during the thermal process used for fabricating the electrodes.

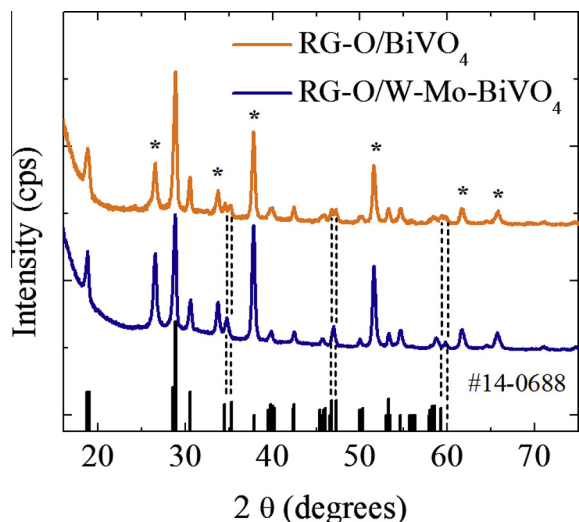


Fig. 4. XRD patterns of RG-O/BiVO₄ (yellow) and RG-O/W-Mo-doped BiVO₄ (blue). The reference patterns of the monoclinic scheelite-like BiVO₄ (PDF#14-0688, bottom line) and patterns from FTO substrate (*) are also indicated. Dotted lines indicate the characteristic shift of peaks from undoped BiVO₄ to the W-Mo-doped BiVO₄. (For interpretation of the references to color in this figure legend, the reader is referred to the web version of this article.)

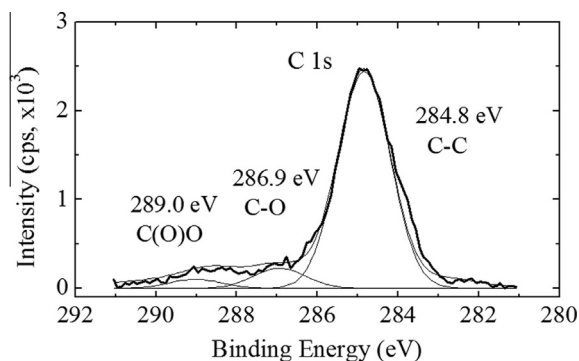


Fig. 5. XPS spectra for C1s of RG-O/BiVO₄ composite electrodes. The RG-O/BiVO₄ was prepared from 5 wt% G-O precursor solution on the FTO substrate. The drop-cast film was annealed at 500 °C for 3 h in air. Note that peaks are shifted (+1 eV) to compensate the sample charging effect in the XPS.

Fig. S2 shows that G-O is thermally reduced at temperatures of about 150 °C and both 400 °C and 450 °C are well above the temperature required for thermal reduction of G-O. XPS spectra for C1s of RG-O/BiVO₄ shown in Fig. 5 indicate that the G-O in the precursor solution is being reduced at the elevated temperatures (see Supporting information Fig. S5 for survey scan) [31]. However, further work is needed to study the chemistry of thermal reduction of G-O in air atmosphere and chemical environments used here, i.e., ethylene glycol. In summary, the photoactivity of RG-O/BiVO₄ composite is greatly affected by the properties of the host BiVO₄. Also, XRD measurements show that RG-O does not disrupt the formation of the BiVO₄ crystal structure for the simple drop-casting method. With properly prepared BiVO₄, the increased photoactivity of the RG-O composite electrodes indicates that RG-O is an excellent additive for the drop-cast BiVO₄ to improve the photocatalytic activity.

3.2. Experiments with RG-O/W-Mo-doped BiVO₄

RG-O composite electrodes with W-Mo-doped BiVO₄ were also prepared. W-Mo-doped BiVO₄ is a photocatalyst with several times greater photoactivity for water oxidation than undoped BiVO₄ [5]. Enhanced separation of excited electron-hole pairs has been suggested as a reason for the improved photoactivity of W-Mo-doped BiVO₄. Briefly, the modified electronic structure of BiVO₄ by doping W and Mo with a small shift of the flat band potential increases the electron (or hole) transfer in BiVO₄ [5]. To determine if a further improvement of photoactivity of the W-Mo-doped BiVO₄ could be realized, an RG-O composite electrode of W-Mo-doped BiVO₄ (RG-O/W-Mo-doped BiVO₄) was prepared from a solution of 5 wt% G-O and metal salts in ethylene glycol. Again note, RG-O does not affect the crystal formation of drop-cast W-Mo-doped BiVO₄ as shown by the XRD (Fig. 4). In other words, XRD patterns of RG-O/W-Mo-doped BiVO₄ show the peaks from monoclinic scheelite-like BiVO₄ along with characteristic peak shifts caused by the tetragonal deformation of the monoclinic scheelite-like BiVO₄ by the doping with W and Mo at 35, 47, and 59° in Fig. 4. However, the observed photoactivity of RG-O/W-Mo-doped BiVO₄ was smaller than that of W/Mo-doped BiVO₄ without RG-O (Fig. 2b). Photocurrent for sulfite oxidation measured at 0.5 V decreased about 40% from 1.7 mA cm⁻² to 1.0 mA cm⁻² by the addition of RG-O to W-Mo-doped BiVO₄ under UV-visible irradiation (see Supporting information Fig. S3 for visible response). The effects of the annealing temperature on the photoactivity were also studied for the RG-O/W-Mo-doped BiVO₄ at temperatures ranging from 450 °C to 550 °C (Supporting information Fig. S6) and RG-O/W-Mo-doped BiVO₄ shows lower photo-

current than W-Mo-doped BiVO₄ at all temperatures. The decrease of photoactivity of RG-O/W-Mo-doped BiVO₄ may imply that RG-O generates a recombination center or electron trap in W-Mo-doped BiVO₄. Also, the results indicate that the increased photocurrent of RG-O/BiVO₄ from BiVO₄ is not due to the increased electrode area or morphological changes of the photoelectrode; if the enhanced photoactivity of RG-O/BiVO₄ was due to the increased surface area of BiVO₄ as shown in the SEM images (Supporting information Fig. S7), a similar effect would also be seen for RG-O/W-Mo-doped BiVO₄.

It is established in sulfite oxidation that the incorporation of RG-O into BiVO₄ improves the photoactivity of undoped BiVO₄ as described above. There has also been a report of the improved PEC water oxidation on RG-O/BiVO₄ composite electrodes [16]. However, we found that the photocurrent measured for water oxidation showed that the increase of photocurrent by RG-O addition to BiVO₄ is less marked for water oxidation than that for sulfite oxidation (Fig. 6a). The enhancement of photocurrent for water oxidation by RG-O addition to BiVO₄ was only about 30% at the potential of 0.6 V from 30 μA cm⁻² to 40 μA cm⁻². Although there is a report of very large increases in photocurrent by addition of RG-O to BiVO₄ from a few μA cm⁻² to tens of μA cm⁻² for water oxidation [16], we have not seen such a large effect. The smaller improvement of photocurrent with RG-O addition to BiVO₄ can be caused

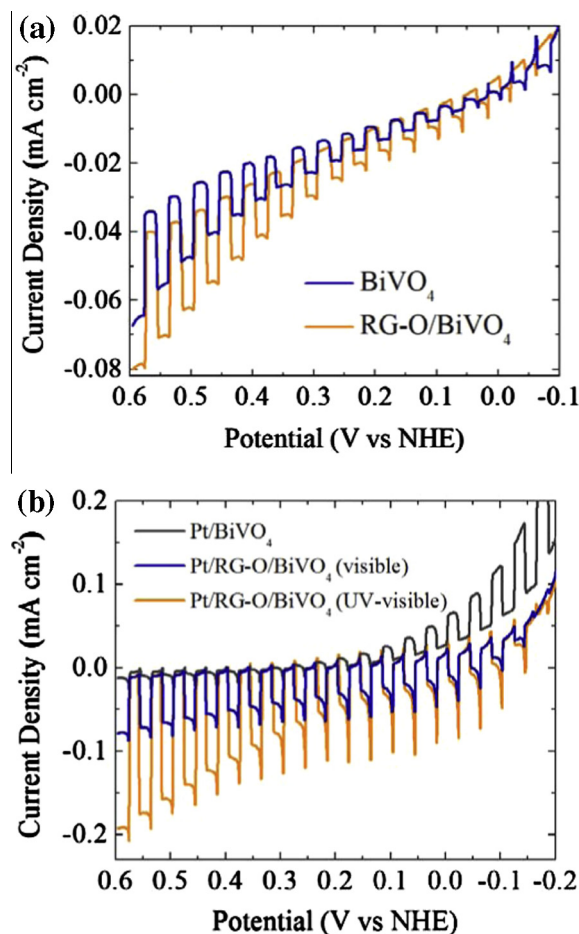


Fig. 6. LSVs of (a) BiVO₄ (blue) and RG-O/BiVO₄ (yellow) and (b) Pt/BiVO₄ (black) and Pt/RG-O/BiVO₄ (blue under visible and yellow under UV-visible irradiation) with photodeposited Pt electrocatalyst for water oxidation in 0.1 M Na₂SO₄ aqueous solution (pH 7, 0.2 M sodium phosphate buffered). Scan rate was 20 mV s⁻¹. Photocurrent was measured under chopped UV-visible irradiation. Beam intensity was about 120 mW cm⁻². (For interpretation of the references to color in this figure legend, the reader is referred to the web version of this article.)

by the slower kinetics of inner-sphere reactions of water oxidation compared with the fast and irreversible sulfite oxidation. In other words, slow charge transfer at the surface from the photocatalyst to the adsorbate is the rate-determining step of photo-induced water oxidation. Improvement in bulk carrier mobility does not help in the effective separation of electron–hole pairs of RG-O/ BiVO_4 for water oxidation; yet is obvious for the fast sulfite oxidation. In addition, for W–Mo-doped BiVO_4 the negative effect of RG-O on the photoactivity of W–Mo-doped BiVO_4 was also confirmed in water oxidation (not shown here).

3.3. Experiments with Pt Electrocatalyst on RG-O/ BiVO_4

To increase the kinetics of water oxidation on BiVO_4 and RG-O/ BiVO_4 , a Pt electrocatalyst was photodeposited onto the electrodes [32]. The results in Fig. 6b shows that for water oxidation the photooxidation current of RG-O/ BiVO_4 increased about five times by the addition of Pt catalyst from $40 \mu\text{A cm}^{-2}$ to $200 \mu\text{A cm}^{-2}$ at 0.6 V. In contrast to RG-O/ BiVO_4 , BiVO_4 without RG-O exhibited no improvement from the catalyst. Pt/ BiVO_4 actually showed slightly lower currents than the film without the electrocatalyst. This suggests that BiVO_4 without G-O still suffers from severe electron–hole recombination that limits the overall rate of the reactions. However, it is also possible that the Pt electrocatalysts were not properly photodeposited on BiVO_4 without G-O as the

BiVO_4 shows poorer photoactivity than RG-O/ BiVO_4 under the given experimental conditions.

3.4. Digital simulations

Finite element analysis was performed to study the effects of addition of RG-O to BiVO_4 . Experimental results shown in Fig. 2 for sulfite oxidation of BiVO_4 were used to fit the simulation parameters, i.e., the hole and electron transfer rate constants (k_f and k_b in Eqs. (14) and (15)), the surface recombination rate constants (k_{SurRec}), the electron and hole mobility (μ_n and μ_p), and the electron and hole recombination lifetimes (τ_n and τ_p) of BiVO_4 .

The simulated LSVs of BiVO_4 , R-GO/ BiVO_4 and W–Mo-doped BiVO_4 electrodes are shown in Fig. 7 with the experimental results. The fitting parameters obtained from simulations are summarized in Tables 1 and 2. The parameters were assigned for the model used and the values are largely determined by the specific calculations in this study. Thus, experiments that are independent of the PEC ones that can provide accurate parameters, such as mobility, are still required to ensure a unique set of properties in the given model. To show the sensitivity of fitting parameters in the model used, simulated LSVs for BiVO_4 are shown with varied values for four different parameters in Supporting information Fig. S8. In the calculations for the BiVO_4 , carrier mobility and lifetime affected the photocurrent densities over wide potential ranges where the rate constants for surface recombination reaction (7) and electro-

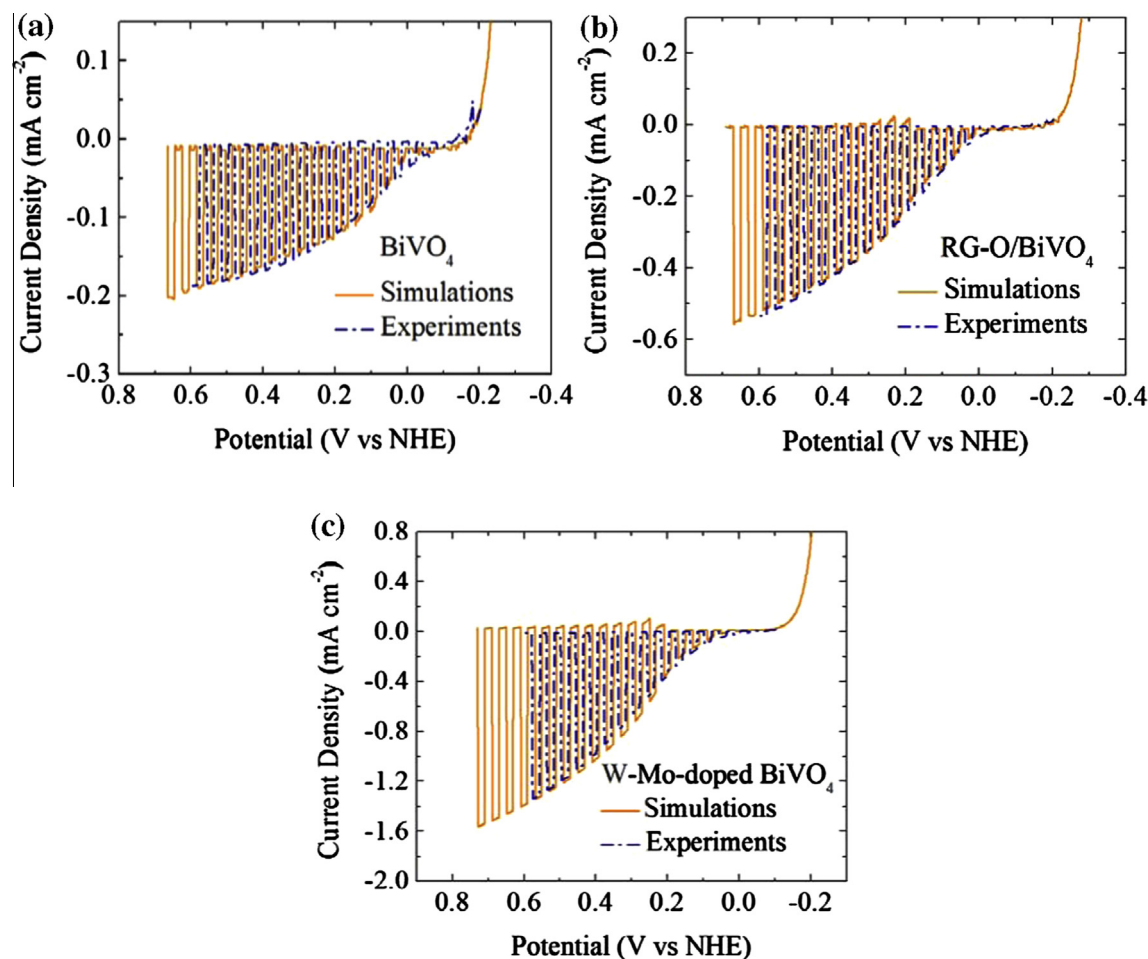


Fig. 7. Comparison of simulated LSVs (yellow solid) to experimental results (blue dash) of (a) BiVO_4 , (b) RG-O/ BiVO_4 , and (c) W–Mo-doped BiVO_4 . The experimental results were taken from Fig. 2 for sulfite oxidation under UV–visible irradiation. Scan rate was 20 mV s^{-1} . Parameters used for simulation fitting were summarized in Table 1 and Supporting information Table S1. (For interpretation of the references to color in this figure legend, the reader is referred to the web version of this article.)

Table 1
Simulation input parameters for BiVO₄, R-GO/BiVO₄, and W-Mo-BiVO₄ electrodes shown in Fig. 7. *The donor doping density (n_d) of W-Mo-BiVO₄ that is larger than BiVO₄ has been reported and the W-Mo-BiVO₄ may also have larger intrinsic doping density (n_i) than BiVO₄ with the higher doping level of W and Mo into BiVO₄. However, n_i was fixed as a constant for the simulations in Fig. 7 for all the electrodes that resulted in the lower n_d for W/Mo-doped BiVO₄ than BiVO₄. (H.S. Park, K.E. Kweon, H. Ye, E. Paek, G.S. Hwang, A.J. Bard, J. Phys. Chem. C, 115 (2011) 17870–17879.)

Parameter	Value			Units	Description
	BiVO ₄	RG-O/BiVO ₄	W-Mo-BiVO ₄		
μ_n	12	150	300	$\text{cm}^2 \text{V}^{-1} \text{s}^{-1}$	Electron mobility
μ_p	2	35	100	$\text{cm}^2 \text{V}^{-1} \text{s}^{-1}$	Hole mobility
τ_n	0.25	0.14	0.33	ps	Electron lifetime
τ_p	0.25	0.14	0.33	ps	Hole lifetime
n_d^*	4×10^{19}	4×10^{18}	1×10^{17}	cm^{-3}	Donor doping density
k_f	8×10^{-17}	8×10^{-17}	1.2×10^{-16}	$\text{cm}^3 \text{s}^{-1}$	Rate constant of reaction (19)
k_b	4×10^{-20}	1×10^{-21}	4×10^{-20}	$\text{cm}^3 \text{s}^{-1}$	Rate constant of reaction (20)
k_{SurRec}	1×10^{-4}	2×10^{-5}	1×10^{-4}	$\text{cm}^4 \text{s}^{-1}$	Rate constant of reaction (7)
E_{FlatBand}	-0.53	-0.41	-0.31	V	Flat band potential vs NHE at pH 7

Table 2
Values calculated from input parameters shown in Table 1.

Parameter	Value			Units	Description
	BiVO ₄	RG-O/BiVO ₄	W-Mo-BiVO ₄		
D_n	3.1×10^{-1}	3.8	7.8	$\text{cm}^2 \text{s}^{-1}$	Electron diffusion coefficient
D_p	5.2×10^{-2}	9.0×10^{-1}	2.6	$\text{cm}^2 \text{s}^{-1}$	Hole diffusion coefficient
L_n	2.8	7.3	16	nm	Electron diffusion length
L_p	1.1	3.5	9.3	nm	Hole diffusion length

chemical reaction (19) showed limited effects near the onset potentials. However, the values given are still useful as relative measures of the properties of the systems investigated here. Thus the electron and hole diffusion lengths ($L_{n/p}$) calculated from its diffusion coefficient and recombination lifetime was 2.8 and 1.1 nm for BiVO₄, respectively.

$$L_{n/p} = (D_{n/p} \times \tau_{n/p})^{0.5} \quad (22)$$

The recombination lifetime (~ 1 ps) and diffusion length (~ 2 nm) of BiVO₄ are similar to that reported for α -Fe₂O₃ which results in poor photoactivity [33]. However, as the RG-O was added to BiVO₄, it provided a better channel for electron transport that increased the electron and hole mobility and the diffusion length. The electron and hole diffusion length increased about three times from 2.8 and 1.1 nm to 7.3 and 3.5 nm with the addition of RG-O to BiVO₄ (Table 2). The electron and hole diffusion length of W-Mo-doped BiVO₄ was even longer than RG-O/BiVO₄ as expected from the measured photocurrent in Fig. 2 (16 and 9.3 nm). However, the obtained electron/hole recombination lifetime of photoelectrodes is extremely short, ~ 0.1 to 0.3 ps. For such an extremely short lifetime, the electrodes prepared by drop casting have many grain boundaries (SEM in Supporting information Fig. S7) that can introduce carrier traps and shorten the electron/hole recombination lifetime. The electron and hole diffusion lengths of BiVO₄, RG-O/BiVO₄, and W-Mo-doped BiVO₄ are still much smaller than, for example, that of TiO₂ ($\sim 10 \mu\text{m}$) and have low fill factors in the current–potential behavior compared with the TiO₂ [34]. However, the digital simulations show that improved electron and hole mobility and lifetime by addition of RG-O or W/Mo into BiVO₄ results in less electron/hole recombination in the bulk semiconductor (Fig. 8a). The peak trap recombination rate of BiVO₄ electrode at 0.6 V (vs NHE) is $15 \times 10^{20} \text{cm}^{-3} \text{s}^{-1}$, and it decreases to $14 \times 10^{20} \text{cm}^{-3} \text{s}^{-1}$ and $12 \times 10^{20} \text{cm}^{-3} \text{s}^{-1}$ in the RG-O/BiVO₄ and W-Mo-doped BiVO₄ electrodes. As the recombination rate decreases, the net flux of minority carrier at the electrode surface increases from $1 \times 10^{15} \text{cm}^{-2} \text{s}^{-1}$ (BiVO₄) to 3×10^{16} (RG-O/BiVO₄) and $9 \times 10^{15} \text{cm}^{-2} \text{s}^{-1}$ (W/Mo-doped BiVO₄) as shown in Fig. 8b. The increased minority carrier flux and reduced recombination rates improves the photoactivity of the RG-O/BiVO₄ and W-Mo-doped BiVO₄.

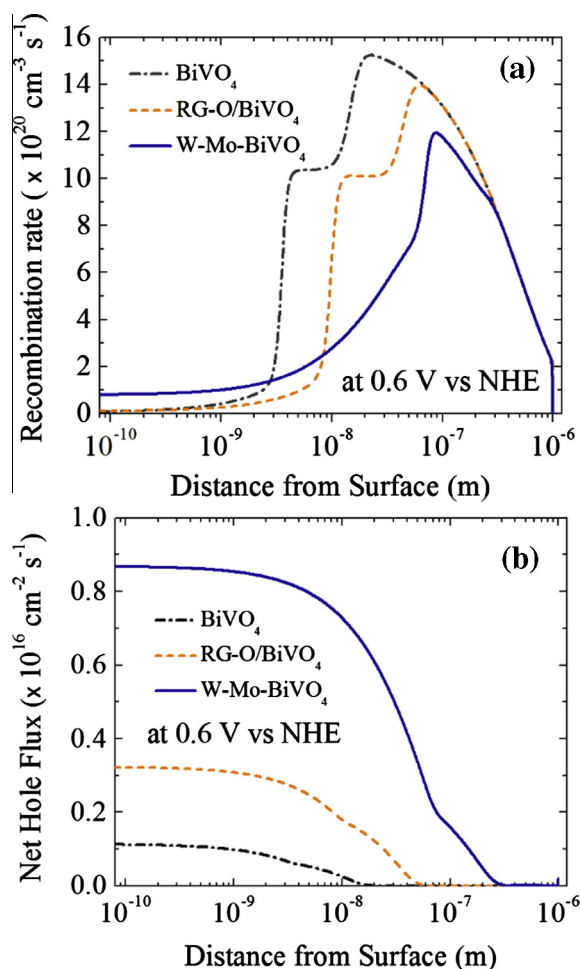


Fig. 8. (a) Recombination rate of electron–hole pairs and (b) net hole flux in BiVO₄ (black dash-dot), RG-O/BiVO₄ (yellow dash), and W-Mo-doped BiVO₄ (blue solid) electrodes from the calculation shown in Fig. 7. (For interpretation of the references to color in this figure legend, the reader is referred to the web version of this article.)

In summary, RG-O/BiVO₄ exhibited significantly improved photoactivity compared to BiVO₄ by the addition of RG-O. The results indicate that RG-O efficiently facilitates the electron–hole separation in BiVO₄ or reduced electron–hole recombination in the bulk electrodes. Moreover, metal doping of W and Mo into BiVO₄ shows a positive effect on the photoactivity of BiVO₄. The quantitative semiconductor properties were estimated using finite element analysis. In addition, an electrocatalyst, Pt, is required to improve the kinetics of water oxidation to realize the effect of reduced electron–hole recombination of the RG-O/BiVO₄ composite photocatalyst.

4. Conclusions

The photoactivity of the photocatalyst, BiVO₄, for sulfite oxidation was improved by about 3 times by the addition of RG-O. Presumably RG-O as a conductive channel of electrons reduces the electron–hole recombination rate, which is the main factor limiting high photoactivity of metal oxide photocatalysts. The improved carrier diffusion length, mobility, and reduced recombination rate by the addition of RG-O and W and Mo dopants into BiVO₄ were studied by digital simulations. As a result of the addition of RG-O and metal dopants, the electron and hole diffusion length increased from 2.8 and 1.1 nm (BiVO₄) to 7.3 and 3.5 nm (RG-O/BiVO₄) and 16 and 9.3 nm (W/Mo-doped BiVO₄). However, improved electron–hole separation was not significant for water oxidation on RG-O/BiVO₄ probably because of the kinetic limitations of the inner-sphere water oxidation surface reaction. Pt electrocatalyst was thus photodeposited onto RG-O/BiVO₄ to decrease the kinetic limitations. The resulting Pt/RG-O/BiVO₄ electrode showed several times higher photocurrent for water oxidation than Pt/BiVO₄ or BiVO₄.

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Appendix A. Supplementary material

Supplementary data associated with this article can be found, in the online version at <http://dx.doi.org/10.1016/j.jelechem.2013.08.036>.

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